

Application No.	Applicant(s)	
10/675,514	HO ET AL.	•
Examiner	Art Unit	
Paul D. Kim	3729	

	SEARCHED				
Class	Subclass	Date	Examiner		
29	603.13- 603.17	5/11/2005	PK		
360	318 321	5/11/2005	PK		
	324-327				
365	158 173				
216	39 41				
427	127 128	<i>\</i>			
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Reviewed Parent Application 09/922,446 (US PAT. 6,657,825)	5/11/2005	PK	
Text Search EAST/NPL (IEEE)	5/12/2005	PK	
Updated Text Search EAST	11/2/2005	PK	